



In re application of

Confirmation No. 1632

Norio KIMURA et al.

Attorney Docket No. 2001-0660A

Serial No. 09/864,208

Group Art Unit 1763

Filed May 25, 2001

Examiner Jeffrie R. Lund

SUBSTRATE POLISHING APPARATUS AND

Mail Stop: RCE

SUBSTRATE POLISHING METHOD

PATENT OFFICE FEE TRANSMITTAL FORM

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO: 28-8975

Sir:

Attached hereto is a check in the amount of \$1,360.00 to cover Patent Office fees relating to filing the following attached papers:

Request for Continued Examination (RCE) \$790.00

Petition for Extension of Time\$570.00

A duplicate copy of this paper is being submitted for use in the Accounting Division, Office of Finance.

The Commissioner is authorized to charge any deficiency or to credit any overpayment associated with this communication to Deposit Account No. 23-0975, with the EXCEPTION of deficiencies in fees for multiple dependent claims in new applications.

Respectfully submitted,

Norio KIMURA et al.

Nils E. Pedersen

Registration No. 33,145 Attorney for Applicants

NEP/krg WENDEROTH, LIND & PONACK, L.L.P. 2033 K St., N.W., Suite 800 Washington, D.C. 20006-1021 Telephone (202) 721-8200 November 3, 2006

[Check No. _ 77][[